

Patent

In the United States Patent and Trademark Office

Date: May 15, 2009

In re Application of: Toshio Sunaga

Filed: 05/08/2006

For: Semiconductor Storage Device and Burst Operation Method
Confirmation No. 4737

Serial Number: 10/595,742

Art Unit: 2827

Examiner: PHAM, LY D

DO NOT ENTER: /LP/
05/21/2009

REPLY AND AMENDMENT UNDER 35 U.S.C. §1.116

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313

DO NOT ENTER: /LP/
05/21/2009

Sir:

This is in response to a final Office Action mailed 3/17/2009, which is due for response by 5/17/2008. Any fees required in entering this response may be charged to Applicant's deposit account, 09-0456.

It is respectfully requested that this Amendment be entered in the above referenced application and reconsideration of the application in view of these comments be made. No new matter has been included. The application should be amended as follows: